



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei YAMAZAKI et al.)
Serial No. 09/334,646)
Filed: June 17, 1999)
For: SEMICONDUCTOR DEVICE AND)
FABRICATION METHOD)
THEREOF)

Art Unit: 2811

Examiner: S. Hu

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 11, 2003.

Adeline M. Stamp

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 11, 2003, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

106. (Amended) The display device according to claim 104, wherein the laser annealing is performed to crystallize an amorphous semiconductor layer in order to obtain a crystalline semiconductor layer.

109. (Amended) The display device according to claim 107, wherein the laser annealing is performed to crystallize an amorphous semiconductor layer in order to obtain a crystalline semiconductor layer.

37# / Amdt J
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